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## BIB DATA SHEET

CONFIRMATION NO. 4375

<b>SERIAL NUMBER</b> 10/514,429	<b>FILING or 371(c) DATE</b> 07/12/2005 <b>RULE</b>	<b>CLASS</b> 313	<b>GROUP ART UNIT</b> 2881	<b>ATTORNEY DOCKET NO.</b> 204552033800		
<b>APPLICANTS</b> Robert Dwilinski, Warsaw, POLAND; Roman Doradzinski, Warsaw, POLAND; Jerzy Garczynski, Lomianki, POLAND; Leszek Sierzputowski, Union, NJ; Yasuo Kanbara, Anan-shi, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP02/13079 12/13/2002 <b>** FOREIGN APPLICATIONS *****</b> <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b>						
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /MICHAEL J LOGIE/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance ml Initials	<b>STATE OR COUNTRY</b> POLAND	<b>SHEETS DRAWINGS</b> 8	<b>TOTAL CLAIMS</b> 7	<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> MORRISON & FOERSTER LLP 1650 TYSONS BOULEVARD SUITE 400 MCLEAN, VA 22102 UNITED STATES						
<b>TITLE</b> Phosphor single crystal substrate and method for preparing the same, and nitride semiconductor component using the same						
<b>FILING FEE RECEIVED</b> 2970	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			